

*Amendment Under 37 C.F.R. §1.312*

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Serial No.: 10/669,384

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Title: METHODS FOR FORMING A CONDUCTIVE STRUCTURE USING OXYGEN DIFFUSION THROUGH ONE METAL LAYER TO OXIDIZE A SECOND METAL LAYER (As Amended)

**Amendments to the Specification**

Please amend the title beginning on page 1, line 5, with the following:

METHODS FOR FORMING A CONDUCTIVE STRUCTURE USING OXYGEN  
DIFFUSION THROUGH ONE METAL LAYER TO OXIDIZE A SECOND METAL LAYER  
FROM A SUBSTRATE THROUGH GRAIN BOUNDARIES OF A FIRST METAL LAYER  
TO OXIDIZE A SECOND METAL LAYER